

Applied Materials (AMAT) Endura II Liner/Barrier

Equipment details:

Currently Configured for: 300mm Asset HDD not included

[Chamber 2] For Ti PVD chamber DCPS;OPTIMA DCG-200,ENI,for PVD PUMP/CRYO,OBIS,HELIX HT ESC type stage Ar;150/20sccm

[Chamber 3] For TiN PVD chamber DCPS;OPTIMA DCG-200,ENI,for PVD PUMP/CRYO,OBIS,HELIX A101 type stage Ar/N2;150/200sccm

[Chamber 4] For TiN PVD chamber DCPS;OPTIMA DCG-200,ENI,for PVD PUMP/CRYO,OBIS,HELIX A101 type stage Ar/N2;150/200sccm [Chamber C]

For Pre-CLN chamber,PCXT RFPS;CDX-2000,13.56/2MHz,COMDEL,for BIAS/ SLA PUMP/TMP MAG1300,LEYBOLD. Ar;200/20sccm

[Chamber D] For Pre-CLN chamber,PCXT RFPS;CDX-2000,13.56/2MHz,COMDEL,for BIAS/ SLA PUMP/TMP MAG1300,LEYBOLD. Ar;200/20sccm

[Chamber E] For Degas,Plate heater PUMP/CRYO,HELIX ON-BOARD IS Ar,press. Controlled

[Chamber F] For Degas,Plate heater PUMP/CRYO,HELIX ON-BOARD IS Ar,press. Controlled